

Receipt

EMC 01-0650(3003)
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of John Davis Holder
Serial No. 10/002,862
Filed November 15, 2001
Confirmation No. 4783



Group Art Unit 1765

For Intermittent Feeding Technique for Increasing
the Melting Rate of Polycrystalline Silicon

March 28, 2002

Office of Initial Patent Examination
Customer Service Center
Assistant Commissioner for Patents
Washington, D.C. 20231

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Sir:

We have received the updated filing receipt in the above-referenced U.S. patent application.

The filing receipt still shows the title as Inermittent Feeding Technique for Increasing the Melting Rate of Polycrystalline Silicon; whereas the correct information is Intermittent Feeding Technique for Increasing the Melting Rate of Polycrystalline Silicon.

* A marked up copy of the filing receipt is attached. Please send us a corrected filing receipt.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "E. Hejlek".

Edward J. Hejlek, Reg. No. 31,525
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EJH/SMR

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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO.	DRAWINGS	TOT CLAIMS	IND CLAIMS
10/002,862 /	11/15/2001 /	1765 /	2490	MEMC 01- 0650 (3003) /	4 /	96	6

 000321
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CONFIRMATION NO. 4783 /

UPDATED FILING RECEIPT



OC000000007506507

Date Mailed: 02/21/2002

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

John Davis Holder, Lake St. Louis, MO; /

Assignment For Published Patent Application

MEMC Electronic Materials, Inc.; /

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted 12/26/2001

Projected Publication Date: 05/15/2003 /

Non-Publication Request: No

Early Publication Request: No

Title

~~Intermittent~~ feeding technique for increasing the melting rate of polycrystalline silicon '
 Intermittent

Preliminary Class

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